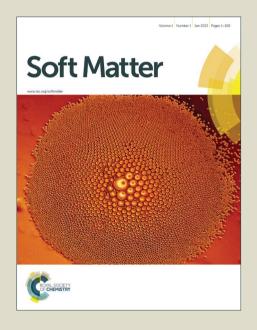
Soft Matter

Accepted Manuscript



This is an *Accepted Manuscript*, which has been through the Royal Society of Chemistry peer review process and has been accepted for publication.

Accepted Manuscripts are published online shortly after acceptance, before technical editing, formatting and proof reading. Using this free service, authors can make their results available to the community, in citable form, before we publish the edited article. We will replace this Accepted Manuscript with the edited and formatted Advance Article as soon as it is available.

You can find more information about *Accepted Manuscripts* in the **Information for Authors**.

Please note that technical editing may introduce minor changes to the text and/or graphics, which may alter content. The journal's standard <u>Terms & Conditions</u> and the <u>Ethical guidelines</u> still apply. In no event shall the Royal Society of Chemistry be held responsible for any errors or omissions in this *Accepted Manuscript* or any consequences arising from the use of any information it contains.



In situ laser-imprinted surface realignment of a nematic liquid crystal

Giorgio Mirri^{1*}, Miha Škarabot¹ and Igor Muševič^{1,2}

¹Condensed Matter Physics Department, Jožef Stefan Institute, Jamova 39, 1000 Ljubljana, Slovenia.

²Faculty of Mathematics and Physics, University of Ljubljana, Jadranska 19, 1000 Ljubljana, Slovenia.

Contact emails: giorgio.mirri@ijs.si; igor.musevic@ijs.si

Abstract

We present a new method for the in-plane realignment of nematic liquid crystals in already fully assembled cells with uni-directionally rubbed polyimide as an aligning layer. We use nematic liquid crystals (NLCs) with a relatively high nematic-isotropic transition temperature and we focus the IR laser beam of the laser tweezers selectively onto one or the other of the inner interfaces. The heat generated by the IR absorption locally melts the liquid crystal and creates an isotropic island with well-defined molecular anchoring at the nematic-isotropic interface. By scanning the laser beam along a pre-defined line, the moving isotropic-nematic interface leaves behind a well oriented LC domain, with LC molecules aligned at 45° to the rubbing direction. If we in addition move the sample with respect to this scanning line, we are able to selectively realign micro-domains of the liquid crystal with respect to the original alignment induced by the PI rubbing. The realignment can be performed independently on each LC-glass interface, thereby producing predefined domains with customized and controllable alignment within an otherwise uniformly aligned cell.

Introduction

Unidirectional planar alignment of liquid crystals plays a fundamental role in liquid crystal display (LCD) technological applications. The most common way of achieving unidirectional alignment is by rubbing a polymer film on a glass with a velvet or cotton cloth. In this case, the alignment mechanism^{2, 3} involves the formation of micro-grooves on the polymer surface.² accompanied by unidirectional stretching of the polymer backbones due to the rubbing process.³ Recently the effect of the grooves on the alignment of the liquid crystal molecules was revised taking into account the azimuthal anchoring strength^{4, 5} and the chemical interaction between the liquid crystal medium and the surface.⁶ Alternative methods have been developed in order to generate patterns of domains with different orientational order with respect to the surrounding. The atomic force microscope (AFM) has been used for this purpose⁷ where the nanometre-sharp AFM tip is scanned in contact with the surface producing nano-grooves and deformation of the polymer chains. Consequently the LC molecules align along the scanning direction of the tip. These domains can be rewritten and they preserve the direction of the last scan.^{8, 9} Because AFM might be impractical for large area patterning, other methods were developed, such as photolithography to generate master masks that can be used to imprint specific patterns onto the aligning photo-active polymer film, 10 while laser induced micropatterning was used to generate pattern domains onto polyimide (PI) films. ¹¹ Furthermore, selfassembling systems were used to obtain uniform alignment in rubbing-free processes. 12 In situ methods have also been developed, such as photo-switchable polymer aligning coatings, e.g. diazobenzene moieties. 13-16 These compounds undergo a reversible molecular isomerization when irradiated with light at a specific wavelength, and specific direction is chosen by using polarised light. Domains can be obtained by means of masks, which on the other hand, require a photolithographic preparation. All described methods give the possibility of patterning liquid crystal cells on a µm-scale. However, the main limitation resides in the difficulties to obtain selective reorientation of the two glass slides at a specific point in the cell in order to obtain micro domain with customized orientation in the bulk cell. In particular, the methods that allow the patterning of each of the two aligning layers before the cell is assembled will require sophisticated assembly process in order to precisely superimpose two realigned areas on the two glasses for the formation of micro domains. On the other hand, the in-situ photoisomerisation of diazabenzene polymers will give rise to equal isomerisation on both glasses. Alignment of LCs can be also achieved by surface memory effect (SME), where the anisotropization of isotropic surfaces can be obtained by contact with anisotropic moieties. It was first observed by Friedel on isotropic surfaces which were in contact with anisotropic crystals.¹⁷ In the '80 of the 20th century Clark reported the SME caused by smectic LCs.¹⁸ The effect was then characterized by Ouchi on unrubbed polymers,¹⁹ and by Myrvold on rubbed PI layers.²⁰ It was proven that this effect is largely enhanced by the hydrophobicity of the surface, due to a partial solubility of the polymer layer by the LC.

Our idea is to modify the surface orientation of a liquid crystal in a controlled and customized way, by local application of a focused laser beam, as shown in Figure 1. This beam dissipates power upon absorption and can locally melt the liquid crystal into the isotropic phase. The molecules at this laser-created interface have a well-defined orientation, which might be locally and permanently imprinted and can overwrite surface rubbing anchoring.

Controllable and focused laser beams have been proven to be a powerful tool in liquid crystal field. Focused beams of laser tweezers were used for localized colloidal manipulation and one-by-one construction of 2D ^{21,22} and 3D ²³ colloidal structures in nematic LCs. In more complex chiral nematic colloidal assemblies, tweezers were used to locally manipulate, cut, join and knit the nematic defect lines around the colloidal particles. ²⁴ Moreover, laser tweezers were used to selectively and unidirectionally reorient bistable liquid crystal structure from homeotropic to planar. ²⁵ The flexibility of this tool in terms of programmability of the movement of the laser

and control over the power and direction, is the fundamental characteristic that we need for our purpose.

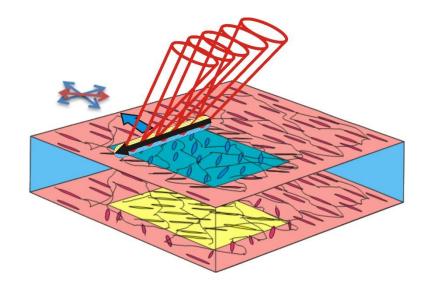


Figure 1. Schematic representation of creating a twisted domain in a uniform planar cell, generated by in-situ patterning. Laser light, represented by the red cones, is focused onto one of the interfaces and is scanned at a very large speed along the direction indicated by the black arrow. In addition, the line is then slowly moved along the surface in the direction of the blue arrow.

Results and Discussions

Materials and Method

We used the liquid crystal MLC 2132 (Merck, Southampton, UK) which has a nematicisotropic transition temperature of 114 °C. The refractive indices of MLC 2132 are n_o = 1.51 and n_e = 1.77. The LC was introduced by capillary force into cells of different thickness (from 10 to 50 μ m), which were assembled by gluing together two glass slides, each of them having a thin layer of indium-tin-oxide (ITO), covered by a thin layer of spin-coated polyimide (PI-2555, NISSAN Chemicals). The two glasses were separated by a suitable spacer. Prior to cell assembly, the PI layer was rubbed to obtain good macroscopic unidirectional alignment. Surface modification was obtained by local heating of the LC using laser tweezers built around an inverted optical microscope with a Nd-YAG laser (1064 nm) that was controlled with an AOD system (see Electronic Supporting Information). The laser tweezers were programmed to

iteratively move the laser focus in one direction along a straight line,²⁶ with the frequencies of 500 to 700 Hz.

Effect of the laser on the alignment of liquid crystal molecules

For a better understanding of the method we should first describe the effect of the laser on the LC and on the polymer. The power of the laser was adjusted in a way that the heat generated by absorption of IR light on only one of the two the ITO layers is sufficient to locally melt the liquid crystal, giving rise to a thin isotropic island, as shown in Figure 2a, which does not extend from one plate to the other. This can be achieved in a cell with thickness down to 5 µm. At the nematic-isotropic (N-I) interface LC molecules are oriented planarly, this can be assessed by using a full-wave retardation plate. 9, 27 In Figure 2a, blueish and yellowish regions (for an explanation on the origin of these colours please refer to the Electronic Supporting Information) of the NLC close to the circumference of the isotropic island clearly indicate planar alignment of the LC molecules at the nematic-isotropic interface.²⁸ When the laser is moved fast along a line the alignment of the LC molecules follows the tailing part of the nematic droplet as clearly visible in Figure 2b, where the laser is moving from bottom to up, therefore the alignment on the two sides of the line corresponds to the alignment of the bottom part of the isotropic island in Figure 2a. When the laser is turned off we notice that the alignment is imprinted on the polymer layer as shown in Figure 2c, this happens when the laser is kept moving along the line for few seconds.

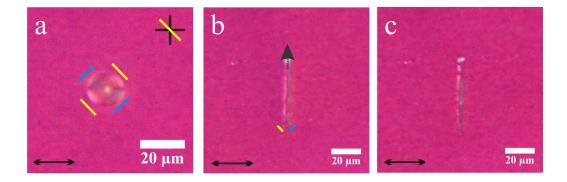


Figure 2. a) An isotropic island, generated by the laser with a frequency of 70 kHz and a laser power of 800 mW, as seen between crossed polarisers and the λ -plate inserted. The laser was focused on one of the two ITO layers, thereby inducing NLC melting from that interface. The black double-headed arrow represents the rubbing direction of a ~19 μ m-thick planar cell. Yellow and blue bars show the direction of local molecular alignment at the isotropic-nematic interface, which is planar. b) The isotropic island, generated by the laser, is now continuously moving along a 50 μ m line, the scanning direction is indicated by the dashed arrow. c) mark left on the surface after the laser was turned off. Black lines indicate the orientation of polariser and analyser, yellow line the direction of the retardation plate.

The "tailing" side of the moving island therefore imprints the molecular orientation, which is present at that interface. Now, having demonstrated the effect of the laser on the liquid crystal medium and on the polymer layer we want to assess if the realignment can be performed to larger areas of the PI layer in a controlled fashion. First we move the sample perpendicular to the laser line (Figure 3) by moving the optical stage. It is clear that such moving of the laser line creates reorientation of LC molecules in the direction, which is determined by the "tailing" side of the moving line. In the experiment this is observed as the fact, that always the back or the tail part of the line determines the observed colour of realigned area. This is true for parallel (Figure 3a-c) and perpendicular (Figure 3d-f) orientation of the laser line with respect to the rubbing direction. The realignment is stable, but can be always reversed by scanning the imprinted area in the opposite direction as shown in Figure 3f.

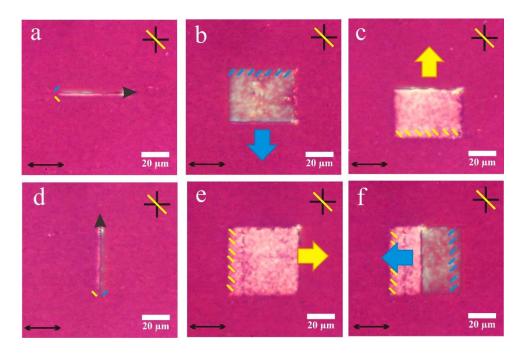


Figure 3. a) A birefringent line, generated by the fast movement of the laser-tweezers parallel to the rubbing as indicated by the arrow. b) In addition to fast laser-scanning in a direction along the rubbing, the line is slowly moved perpendicularly to the

rubbing direction, as indicated by the blue arrow. This leaves behind permanently imprinted surface alignment. c) If the direction of the line movement or slow scanning is reversed, the colour of the imprinted area changes from bluish in panel b) to yellowish. d) A birefringent line, generated by the fast movement of the laser-tweezers perpendicular to the rubbing in the direction of the arrow. e,f) laser line moved along the rubbing direction. When the scanning direction is reversed the alignment follows the alignment on the other side of the line. The cell thickness is $19 \mu m$. Black lines indicate the orientation of polariser and analyser, yellow line the direction of the retardation plate.

In the second experiment the fast movement of the laser was oriented along a line at 45° with respect to the rubbing direction and the slow scanning is again performed parallel or perpendicular to the original rubbing direction (Figure 4). Here the line in Figure 4a appears mostly blue with yellowish side bands, whereas perpendicular line in Figure 4b appears mostly yellowish with bluish edges. Now, when the slow-axis scanning is turned-on, as shown in Figures 4 c and d, the imprinted regions appear yellowish (Figure 4c) or bluish (Figure 4d).

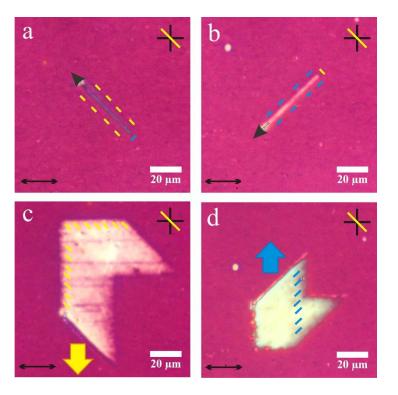


Figure 4. a), b) LC reoriented lines generated by the laser moving along a 50 μ m linear path 45° with respect to the original rubbing direction in the direction of the arrows. c), d) Realignment caused by the slow motion of reoriented lines in the direction of the arrows. Black lines indicate the orientation of polariser and analyser, yellow line the direction of the retardation plate.

The LC reorientation is similar to the previous case, since it always follows the orientation around the tailing part of the isotropic island with respect to the slow movement of the line on the surface. Here the realignment is parallel to the laser line.

The main feature of this method is that the realignment can be carried out independently on each surface of the cell by just changing the focus of laser. The only requirement is that the cell is thick enough in order to allow the creation of the isotropic island on one surface only, without extending over the whole thickness of the cell. When both surfaces are laser-realigned with a fast scanning axis at +/- 45° with respect to the rubbing direction in a planar cell, one can obtain 90° TN or planar LC pixels, as shown in Figure 5. One can clearly see a checkboard pattern of micro-sized pixels with alternating twisted and parallel orientation, all with a different orientation with respect to the original rubbing direction, as indicated by the blue and orange double headed arrows in Figure 5b. The intersections between parallel oriented areas are actually parallel cells, therefore appear black in cross conditions with polariser parallel and analyser perpendicular to the nematic director (black squares in Figure 5b). Intersections of two perpendicularly oriented areas on the two glasses are in any aspect similar to twisted cells (white squares in Figure 5b). Figure 5c shows the pattern under parallel analyser and polariser 45° with respect to the original rubbing direction. In this case twisted cell appear black and parallel cell appear white.

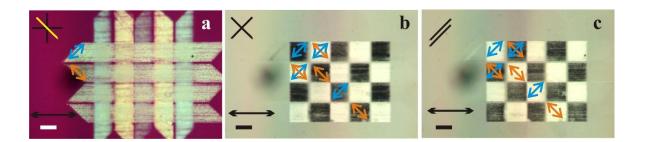


Figure 5. a) Realignment performed onto both glasses of a 30 μ m cell. Colour lines are on the glass further from the objective and closer to the light source. Black arrows indicate the orientation of polariser and analyser, yellow arrow the direction of the retardation plate. b) Same area as a) observed between cross analyser and polariser at 45° to the original rubbing direction; c) Same area as a), but now observed in parallel condition with the polariser and analyser 45° to the original rubbing direction. Scale bars are all 40 μ m. Coloured double headed arrows indicate the director in the realigned area; black double headed arrows indicate the initial rubbing direction.

AFM study of the polymer surface

Next we study the effect of imprinting process on the polymer layer. We imprint a new realignment with a recognisable pattern on the surface as shown in Figure 6a. At the end of

each realigning process we keep the line in the same position for at least 5 seconds, the laser is then turned off leaving the two marks in a way to resemble the symbol (<). We then open the cell and wash out the liquid crystal. Using optical microscope we can only observe the two lines on the positions where the laser is left scanning for a longer time (Figure 6b). To check the memory effect on the polymer layer, we place a small droplet of a 5CB nematic LC on the same spot and the LC is covered with a thin slit glass. The LC preserves the new imprinted orientation (Figure 6c), that is a clear evidence of the permanent realignment of PI layer. Finally, after again having washed the LC out of the surface, we check the effect of the laser induced polymer modification using atomic force microscopy (AFM). We can clearly observed burned polymer at the two positions observed already with optical microscope (figure 6d), but we cannot observe any reorientation of the polymer, which probably occurs at a molecular scale and cannot be observed on a relatively rough polymer surface. The only measurable effect is the increase of surface roughness due to the imprinting process. In particular, the realigned areas have been estimated to have a roughness parameter $R_q \approx 0.9 \pm 0.1$ (Figures 6 f and g) whereas the roughness of non-scanned area is smaller $R_q \approx 0.6 \pm 0.1$ (Figure 6e). This result is important for future technological application of this methodology.

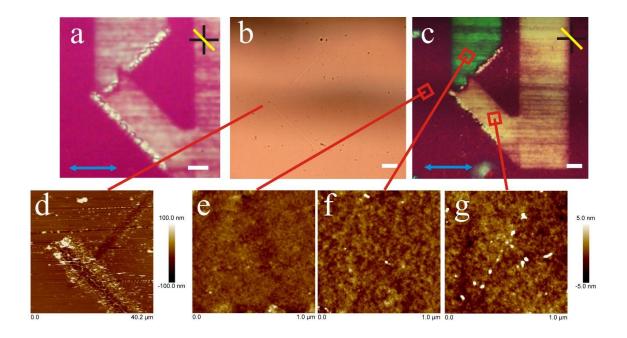


Figure 6. a) transmission mode optical microscopic image of the imprinted area before the LC was washed out; b) Reflection optical microscopic image of the imprinted area after the cell was opened and the LC washed out; c) reflection optical microscopic imagine of the imprinted after the original cell was opened and LC washed out, a droplet of 5CB was placed between one of the imprinted glasses and a cover slip Black lines indicate the orientation of polariser and analyser, yellow line the direction of the retardation plate, blue line is the direction of rubbing. Scale bars are all 30 μ m. d-g) AFM images of the indicated areas in tapping mode. The increase of roughness of imprinted area (f,g) in comparison to non-imprinted can be resolved.

Thermal stability of the realignment and surface memory effect (SME)

The stability of the imprinting process is also confirmed by heating up the sample above the transition temperature (114 °C for MLC 2132). We observe that the realignment is completely recovered when the LC is cooled back down to the nematic phase. Figure 7 shows images of such heating and cooling cycles where laser induced realignment is completely preserved. It is worth noting that the isotropic phase starts in droplets on the non-imprinted area (Figure 7, first panel heating row) but covers completely the realigned area on the glass nearer to the heater (Figure 7, second panel heating row). This is due to the increased wettability of the isotropic LC in the realigned area compared to the non-imprinted one, caused most probably by the modification of the surface of the polymer layer on the molecular scale.

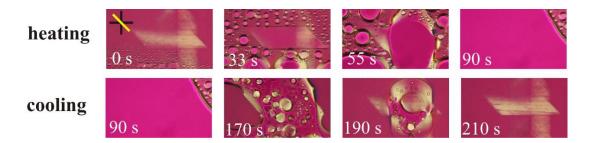


Figure 7. Imprinted area at the nematic – isotropic transition of the medium. The horizontal white imprinted area is on the bottom glass closer to the heater, the blue and yellow line are on the other glass. Black lines indicate the orientation of polariser and analyser, yellow line the direction of the retardation plate.

The imprinted realignment can be decreased only by several repetition of heating-cooling cycles to temperatures 30-40 °C higher than the clearing temperature of the liquid crystalline medium as showed in Figure 8.

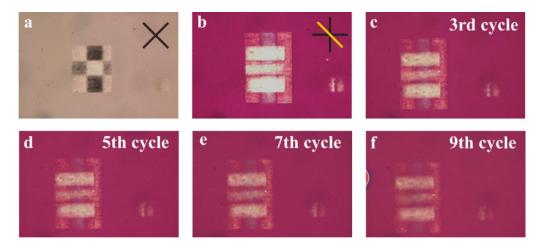


Figure 8. a) and b) imprinted area with polarisers oriented as described; c-f) imprinted area after three, five, seven and nine heating-cooling cycles to the isotropic phase at 150 °C. Black lines indicate the orientation of polariser and analyser, yellow line the direction of the retardation plate.

The temperature stability of laser induced realignment is a clear evidence that reorientation of LC molecules induce realignment of the polymer surface. This surface memory effect can be also observed in cells without PI layer as shown in Figure 9. In the absence of aligning agents the LC has a degenerated planar alignment, i.e. the molecules lie parallel to the surface without a preferential azimuthal direction. Under cross polarisers conditions the texture is characterised by the presence of black stripes that correspond to areas where the LC molecules are aligned with one of the polarisers. By focussing the laser line on one of the surfaces and moving it in different direction we observe a change in the alignment of the LC, which is evidenced by the narrowing of the Schlieren line as clearly visible in the two ellipses in the first and in the last panel of Figure 9. The only difference from the effect obtained in uni-directionally rubbed cells is that in the case of degenerated planar realignment we lose control over the direction of the realignment, since the initial planar distribution around the isotropic island is linked to the uniform director of the LC.

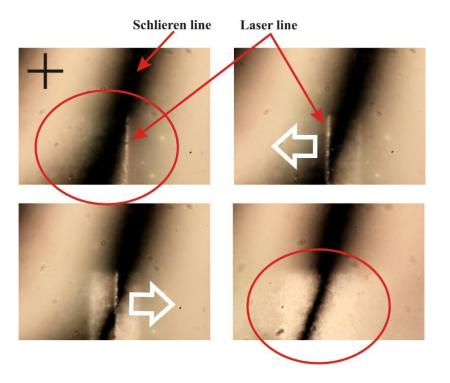


Figure 9. Application of the realigning method to a cell without PI coating. The arrows indicate the direction of the slow motion of the laser. Black lines indicate the orientation of polariser and analyser. In the last panel the laser is switched off and the effect of realigning can be seen as narrowing of the Schlieren line.

This is the demonstration that this method represents, to the best of our knowledge, the first example of direct control of the SME of the liquid crystal, on rubbed PI, in all its aspects; direction of alignment, size and shape of the realigned domains.

Flexibility of the method

With this LC system the smallest pixel size obtainable is about $10 \times 10 \ \mu m^2$. In fact, under the presented experimental conditions, using lines shorter than $10 \ \mu m$ is indeed more difficult to obtain a uniformly realigned region as shown in Figure 10a. At last we demonstrate the flexibility of this method. Figures 10b and c show two "handmade" pictures obtained by moving the laser line with the length of 12.5 μm . These pictures demonstrate that the realignment process can be used to produce any kind of pattern. The draws showed in Figure 10 were manually prepared and their quality depends only on the skills of the operator. The quality could be improved by electronically controlling the movement of the sample to move along a programmed path.

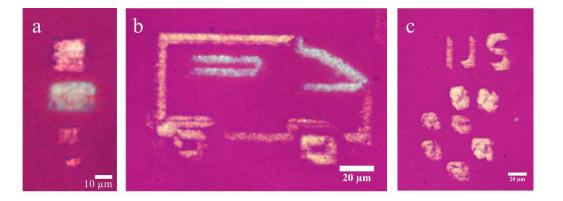


Figure 10. a) The smallest pixels obtainable with this process. b) "Free hand" drawing of a van and c) of the logo of Jožef Sefan Institute, both drawn realigning LC medium with the proposed method.

Conclusions

To summarise, we developed a new method that allows for the customised and selective in-situ patterning of liquid crystal cells on a µm scale by controlling the SME of LC media on uni-directionally aligned polymer layers. The realignment is carried out by fast scanning of a focused IR laser beam along a line and by moving it across the sample. The realignment occurs solely by focussing the IR laser beam on one of the ITO glasses, where a strong absorption of light results in local increase of the temperature which causes localised melting of a liquid crystal. The realignment is imprinted by the tailing line of the nematic-isotropic interface and it is rather thermally stable, i.e. it is preserved after heating into the isotropic phase and cooling to the nematic phase. Moreover, AFM showed that the topography of the surface is only limitedly affected by the imprinting process. Compared to other methods this one has the advantage that it does not involve photolithographic processes and can be independently applied on each surface of the liquid crystal cell. In LCD manufacturing this method could be used to generate patterned micro-twisted pixels.

Acknowledgments This research was supported by a Marie Curie Intra European Fellowship (Nemcode MC-PEOPLE-IEF-2012-331350) within the 7th European Community Framework Program. G.M. Would like to thank also Gregor Posnjak for his help in programming the laser.

Contribution of the Authors: G.M. ideated and carried out the experiments in addition to draft the manuscript. M.Š. carried out AFM imaging and roughness measurements and revised the manuscript. I.M. mentored G.M. and revised the manuscript.

References

- 1. J. Hoogboom, T. Rasing, A. E. Rowan and R. J. M. Nolte, *J. Mater. Chem.*, 2006, **16**, 1305-1314.
- 2. D. W. Berreman, *Phys. Rev. Lett.*, 1972, **28**, 1683-&.
- 3. J. M. Geary, J. W. Goodby, A. R. Kmetz and J. S. Patel, *J. Appl. Phys.*, 1987, **62**, 4100-4108.
- 4. J. Fukuda, M. Yoneya and H. Yokoyama, *Phys. Rev. Lett.*, 2007, **98**.
- 5. J. Fukuda, J. S. Gwag, M. Yoneya and H. Yokoyama, *Phys. Rev. E*, 2008, **77**.
- 6. L. Cattaneo, J. Zhang, M. Zuiddam, M. Savoini and T. Rasing, *Nano Lett.*, 2014, **14**, 3903-3907.
- 7. J. H. Kim, M. Yoneya and H. Yokoyama, *Nature*, 2002, **420**, 159-162.
- 8. A. Rastegar, M. Skarabot, B. Blij and T. Rasing, J. Appl. Phys., 2001, **89**, 960-964.
- 9. I. I. Smalyukh, R. Pratibha, N. V. Madhusudana and O. D. Lavrentovich, *Eur. Phys. J. E*, 2005, **16**, 179-191.
- 10. J. Kim, Y. W. Lim, J. H. Na and S. D. Lee, *Appl. Opt.*, 2013, **52**, 1752-1757.
- 11. X. Li, X. M. Lu, Q. H. Lu and C. A. Ohlin, *Jpn J Appl Phys 2*, 2006, **45**, L591-L594.
- 12. J. Hoogboom, J. A. A. W. Elemans, T. Rasing, A. E. Rowan and R. J. M. Nolte, *Polym. Int.*, 2007, **56**, 1186-1191.
- 13. W. M. Gibbons, P. J. Shannon, S. T. Sun and B. J. Swetlin, *Nature*, 1991, **351**, 49-50.
- 14. P. Wolfer, K. Kreger, H.-w. Schmidt, N. Stingelin and P. Smith, *Mol. Cryst. Liq. Cryst.*, 2012, **562**, 133-140.
- 15. A. Martinez, H. C. Mireles and I. I. Smalyukh, P Natl Acad Sci USA, 2011, 108, 20891-20896.
- 16. T. Seki, S. Nagano and M. Hara, *Polymer*, 2013, **54**, 6053-6072.
- 17. G. Friedel, Ann. Phys. (Paris), 1922, 18.
- 18. N. A. Clark, Phys. Rev. Lett., 1985, **55**, 292-295.
- 19. Y. Ouchi, M. B. Feller, T. Moses and Y. R. Shen, *Phys. Rev. Lett.*, 1992, **68**, 3040-3043.
- 20. B. O. Myrvold, *Liq. Cryst.*, 1995, **18**, 287-290.
- 21. I. Muševič, M. Škarabot, U. Tkalec, M. Ravnik and S. Žumer, *Science*, 2006, **313**, 954-958.
- 22. G. Mirri, V. S. R. Jampani, G. Cordoyiannis, P. Umek, P. H. J. Kouwer and I. Muševič, *Soft Matter*, 2014.
- 23. A. Nych, U. Ognysta, M. Škarabot, M. Ravnik, S. Žumer and I. Muševič, *Nat. Commun.*, 2013, **4**, 1489.
- 24. U. Tkalec, M. Ravnik, S. Čopar, S. Žumer and I. Muševič, *Science*, 2011, **333**, 62-65.
- 25. V. S. R. Jampani, M. Škarabot, H. Takezoe, I. Muševič and S. Dhara, *Opt. Express*, 2013, **21**, 724-729.
- 26. The length of the linear segment can change depending on the working distance of the objective. In some cases the segment was rescaled keeping constant the number of steps. For the actual length in each experiment refer to the scale bars.
- 27. U. Tkalec, M. Škarabot and I. Muševič, *Soft Matter*, 2008, **4**, 2402-2409.
- 28. M. Škarabot, Ž. Lokar and I. Muševič, *Phys. Rev. E*, 2013, **87**.